

Image AF / 282B



Attention: Mail Stop AF
Response Under 37 C.F.R. § 1.116
Expedited Procedure Requested
Examining Group 2823

PATENT
Customer No. 22,852
Attorney Docket No. 03180.0289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Masayuki TANAKA, et al.) Group Art Unit: 2823
Serial No.: 09/973,744) Examiner: Fourson III, George R.
Filed: October 11, 2001)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE AND)
THE SEMICONDUCTOR DEVICE)

*Please
Print
G 3/8/04*
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action of November 20, 2003, with a period for response extending through February 20, 2004, Applicants propose amending the application as follows. Applicants also respectfully request the Examiner's reconsideration in view of remarks that follow:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.

Remarks begin on page 8 of this paper.

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